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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	09/373,355-2515
				Filing Date	August 12, 1999
				First Named Inventor	Garo J. Derderian
				Group Art Unit	2811
				Examiner Name	C. Nguyen
				Attorney Docket Number	M4065.0069/P069-A
Sheet	1	of	1		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
in	A	"Low-temperature organometallic chemical vapor deposition of platinum", by Yea-jeer Chen, etc., Appl. Phys. Lett., Vol. 53, No. 17, October 24, 1988, pp. 1591-1592.	

Examiner Signature		Date Considered	03-15-02
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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